

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4575**  
Akihisa HONGO et al. : Attorney Docket No. 2006\_0835A  
Serial No. 10/581,669 : Group Art Unit 3723  
Filed June 5, 2006 : Examiner Eileen P. Morgan

POLISHING APPARATUS AND  
SUBSTRATE PROCESSING APPARATUS : 

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**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement of June 23, 2009, Applicants hereby elect the invention of Group II, claims 11-16, without traverse, for further prosecution. In view of this election, a full examination on the merits of the present application is respectfully requested.

If there are any issues that the Examiner feels may best be resolved through a personal or telephone interview, the Examiner is kindly requested to contact the undersigned at the telephone number listed below.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Akihisa HONGO et al.

/Jeffrey J. Howell/  
By: 2009.07.23 10:36:41 -04'00'

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